

	IN THE UNITED STATES PATENT AND TRADEMARK OFFICE			
Rho Application of:				
Ayazi, et al.	Confirmation No.:			
Serial No.: 10/669,178	Group Art Unit:			
,	Examiner:			
Filed: September 23, 2003	Docket No.: 62020-1450			
For: Electrically Coupled M	Micro-Electro-Mechanical Filter Systems and Methods			
•	INFORMATION DISCLOSURE STATEMENT			
Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 2231	3-1450			
Sir:				
This information	disclosure statement is filed in accordance with 37 C.F.R. §§ 1.56, 1.97, and 1.98, and specifically:			
(within Th	CFR 1.97(b), or ree months of filing national application; or date of entry of international application; or before te of first office action on the merits; whichever occurs last)			
under 37	CFR 1.97(c) together with either a: Statement Under 37 C.F.R. 1.97(e), or a \$180.00 fee under 37 CFR 1.17(p), or (After the CFR 1.97(b) time period, but before the final office action or notice of allowance, whichever occurs first)			
under 37	CFR 1.97(d) together with a: Statement under 37 CFR 1.97(e), and a \$180.00 petition fee set forth in 37 CFR 1.17(p). (Filed after final office action or notice of allowance, whichever occurs first, but before payment of the issue fee)			
	g the pendency of this application, please charge any fees required to Deposit Account 20-0778 pursuant missioner is hereby requested to credit any overpayment to Deposit Account No. 20-0778.			
(where required) believe(s) may or	of patents, publications or other information of which applicant(s) are aware, which applicant(s) may not be material to the examination of this application and for which there may be a duty to disclose a 37 CFR 1.56. As required by 37 C.F.R. §1.98(a), a legible copy of each document is provided.			
other foreign lang 37 CFR 1.56(c) m is cited in a seam language version of	ation of the relevance of foreign language patents, foreign language publications and guage information listed on PTO Form 1449, as presently understood by the individual(s) designated in nost knowledgeable about the content is given on the attached sheet, or where a foreign language patent ch report or other action by a foreign patent office in a counterpart foreign application, an English of the search report or action which indicates the degree of relevance found by the foreign office is listed 1449 and is enclosed herewith.			

The following rights are reserved by the Applicant(s): the right to establish the patentability of the claimed invention over any of the listed documents should they be applied as reference, and/or the right to prove that some of these documents may not be enabling for the teachings they purport

This statement should not be construed as a representation that an exhaustive search has been made, or that information more material to the examination of the present application does not exist. Any statements or identifications regarding the relevance of any portion(s) of cited references should not be construed as a representation that the most relevant portion(s) have been identified, and the absence of such statements or identifications should not be construed as representations that there are no relevant portion(s). The Examiner is specifically requested not to rely solely on the materials submitted herewith. The Examiner is requested to conduct an independent and thorough review of the documents, and to form independent opinions as to their significance.

It is requested that the information disclosed herein be made of record in this application and that the Examiner initial and return a copy of the enclosed PTO-1449 to indicate the documents have been considered.

Respectfully Submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as "First Class Mail," in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 2-10-04

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Form PTO-1449					Attorney Docket No. 62020-1450			Serial No. 10/669,178		
(Use several sheets if necessary)					Applicant Ayazi, et al.					
					Filing Date September 23, 2003		Grou	p		
			U.S. PA	TENT DOCUMEN	TS		-	<u> </u>		
Examiner Initials	Item	Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate		
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·	<u></u>		FOREIGN	PATENT DOCUM	ENTS	<u> </u>				
		Document Number	Date	Country		Class	Subclass	Translation		
								Yes No		
	В	WO 02/01717 A1	1/3/02	PCT				Abstract		
	С	WO 03/043189 A2		PCT				Abstract		
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		considered. Include copy of the GNATURE:	ns torm with nex		CONSIDERED:	·				
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